



Docket No. YOR920030175US1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Patent Application**

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Applicant(s): Allen et al.  
Case: YOR920030175US1  
Serial No.: 10/661,041  
Filing Date: September 12, 2003  
10 Group: 2811  
Examiner: Cuong Q. Nguyen

I hereby certify that this paper is being deposited on this date with the U.S. Postal Service as first class mail addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature: *Susan Fortune* Date: November 1, 2005

Title: Techniques for Patterning Features in Semiconductor Devices

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**RESPONSE AFTER FINAL REJECTION**

20 Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

25 Sir:

In response to the outstanding final Office Action dated July 1, 2005, Applicants submit the following remarks.